Search Notes



Applicat	ion/Control	No.

Applicant(s)/Patent under Reexamination

CHMELA ET AL.

10/684,829

Examiner

Art Unit

John T. Kwon

3747

	SEARCHED				
Class	Subclass	Date	Examiner		
123	299	11/1/2005	JK		
	305				
	294				
	501				
	568.14				
	301				
	568.21				

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
all of the	e above	11/1/2005	JK		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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